



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 14, 2026	
IGI Report Number	LG800663849
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	10.46 X 7.19 X 4.85 MM

GRADING RESULTS

Carat Weight	3.08 CARATS
Color Grade	E
Clarity Grade	VS 1

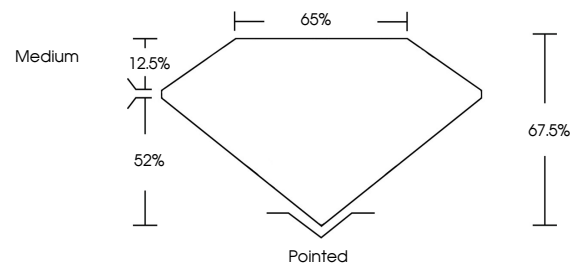
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG800663849

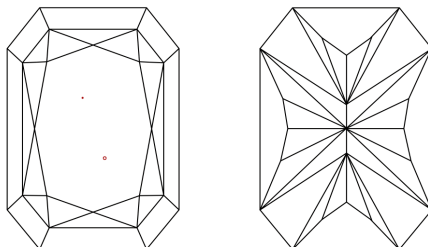
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG800663849
Report verification at igi.org

PROPORTIONS

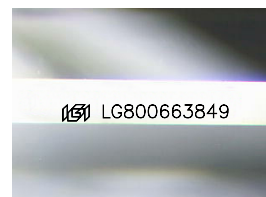


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

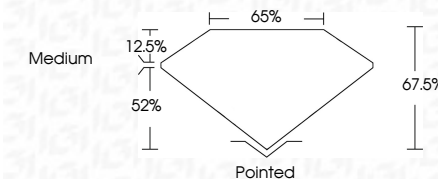
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www.igi.org

	V8 1	Painted
	67.5%	EXCELLENT
	65%	BETTER
	Medium	Fairly Good
		Satisfactory
		Fair
		Good
		Very Good
		Excellent
		NONE
		(#) L90R063849

Comments:

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Type IId